

FORM HDP-1449 (Based on Form PTO-1449)		ATTORNEY DOCKET No. 1740-000003/US	APPLICATION No. 10/780,756
PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		APPLICANT Jin Yong KIM et al.	
		FILING DATE February 19, 2004	GROUP 2134

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U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.		5,940,364	08-17-1999	Ogata et al.		
2.		5,706,268	01-06-1998	Horimai		
3.		2003/0112736	06-19-2003	Muramatsu et al.		
4.		2001/0038603	11-08-2001	Kondo et al.		

FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	No
5.		EP 0 299 573	07-08-1988	EPO			
6.		EP 1 168 312	09-07-2000	EPO			
7.		KR 10-2001-0088053	09-26-2001	Korea		Abstract	
8.		KR 10-1999-0079395	11-05-1999	Korea		Abstract	
9.		EP 1 065 659	01-03-2001	EPO			
10.		EP 1 189 213	03-20-2002	EPO			
11.		JP 2001-014796	01-19-2001	Japan		Abstract	
12.		JP 2000-123479	04-28-2000	Japan		Abstract	
13.		JP 08-036803	02-06-1996	Japan		Abstract	
14.		JP 2001-135021	05-18-2001	Japan		Abstract	
15.		JP 2002-132457	05-10-2002	Japan		Abstract	
16.		WO 01/88917	11-22-2001	WIPO		Abstract	

Examiner: /David Jung/	Date Considered: 11/22/2008
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EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Sheet 2 of 2

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2134

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
17.		Office Action for related U.S. patent application no. 10/426,020 dated August 1, 2008.
18.		Office Action for related European patent application no. 07023886.0-2210 dated March 25, 2008.
19.		Office Action for related Korean patent applicatio no. 10-2007-0042296 dated July 22, 2008.
20.		Office Action for related Korean patent application no. 10-2002-0023983 dated May 30, 2008.
21.		Office Action for related European patent application no. 03721120.8-2210 dated March 14, 2008.
22.		Office Action for related Japanese patent application no. 2005-214336 dated June 3, 2008.

Examiner: /David Jung/

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